

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Fumio KOYAMA et al.

Application No.: New Rule 53(b) Divisional of  
U.S. Patent Application No. 10/026,637

Filed: March 17, 2004

Docket No.: 111587.01

For: SURFACE EMITTING SEMICONDUCTOR LASER  
AND MANUFACTURING METHOD THEREOF

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Specification; and**

**Remarks.**